

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>			Docket Number (Optional) 3996.2US (99-0254.02/US)		Application Number Not Yet Assigned	
			Applicant Warren M. Farnworth			
			Filing Date September 26, 2003		Group Art Unit Unknown	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/LBT/	5,173,220	12/1992	Reiff et al.			
	5,264,061	11/1993	Juskey et al.			
↓	5,484,314	01/1996	Farnworth			
/LBT/	5,705,117	01/1998	O'Connor et al.			

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER /Leo B. Tentoni/	DATE CONSIDERED 08/08/2007
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.



PTO/SB/08B(10-01)

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet 4 of 6

Complete if Known

Application Number	10/672,098
Filing Date	September 26, 2003
First Named Inventor	Warren M. Farnworth
Group Art Unit	Unknown
Examiner Name	Unknown
Attorney Docket Number	3996 211S (99-0254 02/LIS)

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
LBT		U.S. Patent Application Publication 2003/0176016 A1 to Grigg, dated September 18, 2003	
		U.S. Patent Application Publication 2003/0193092 A1 to Tan et al., dated October 16, 2003	
		U.S. Patent Application Publication 2003/0201531 A1 to Farnworth et al., dated October 30, 2003	
		U.S. Patent Application Publication 2003/0203158 A1 to Farnworth et al., dated October 30, 2003	
		U.S. Patent Application Publication 2003/0203612 A1 to Akram et al., dated October 30, 2003	
		U.S. Patent Application Publication 2003/0205849 A1 to Farnworth, dated November 6, 2003	
		MILLER et al., "Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22	
		MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, page 16	
↓		Webpage, Objet Prototyping the Future, "Objet FullCure700 Series", 1 page (UNDATED),	
LBT		Webpage, Objet Prototyping the Future, "How it Works", 2 pages (UNDATED).	
Examiner Signature	/Leo B. Tentoni/		Date Considered 09/28/2006

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¹ Unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

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